

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q85096

Masamichi INENAGA, et al.

Allowed: June 5, 2008

Appln. No.: 10/516,693

Group Art Unit: 2886

Confirmation No.: 6877

Examiner: Isiaka O. Akanbi

Filed: December 6, 2004

Issued: October 14, 2008

U.S. Patent No.: 7,436,513

For: WAFER PRE-ALIGNMENT APPARATUS AND METHOD

SUBMISSION OF ART

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

For the possible benefit of anyone subsequently evaluating the scope and/or validity of the above-identified patent, it is requested that the document that is listed below (copy enclosed) be placed in the U.S. Patent and Trademark Office's file wrapper of the above-identified U.S. patent:

JP-A-09-229713

JP-A-2002-158275

The undersigned has not reviewed the teachings of the above-listed document in detail and thus makes no representations concerning the relevancy or materiality of the above-listed document.

This is not an Information Disclosure Statement and no response from the U.S. Patent and Trademark Office is believed to be necessary, nor are any fees believed to be due.

Respectfully submitted,

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Date: October 6, 2008